

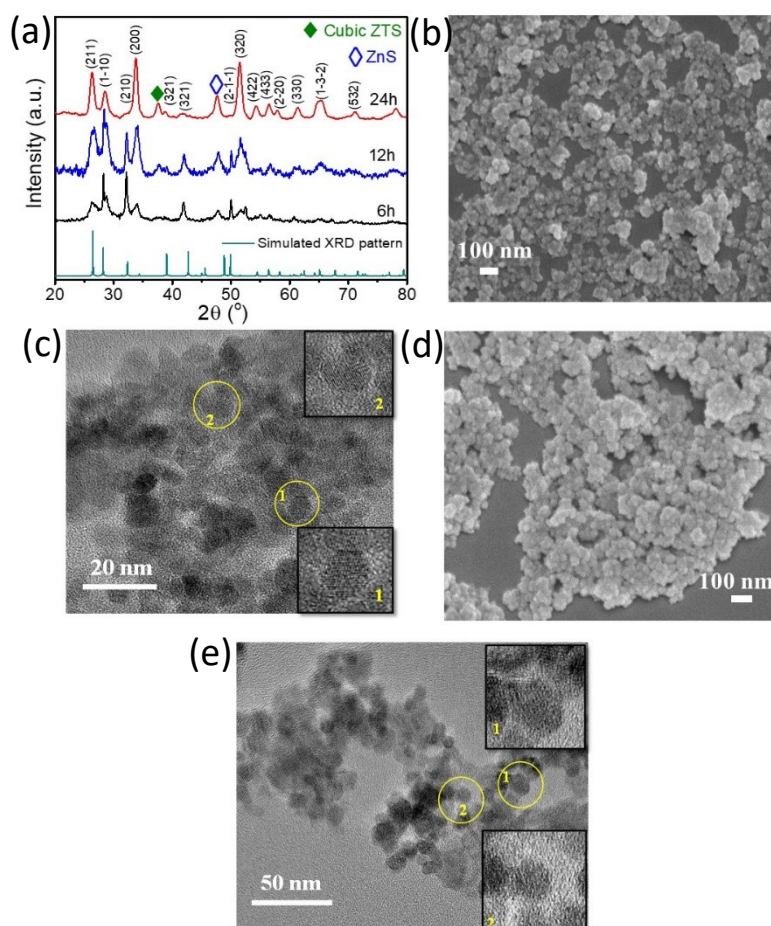
## Supporting Information

### Exploring Piezoelectric and Piezophototronic Properties of Nanostructured LN-ZnSnS<sub>3</sub> for Photo Responsive Vibrational Energy Harvesting

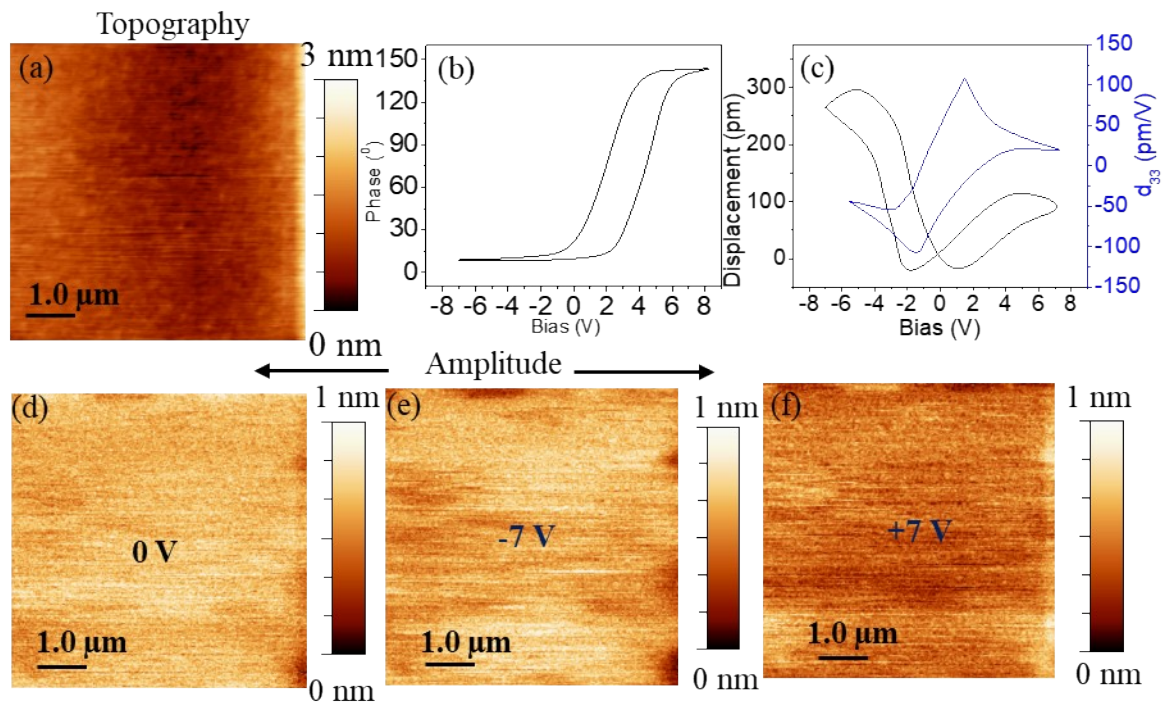
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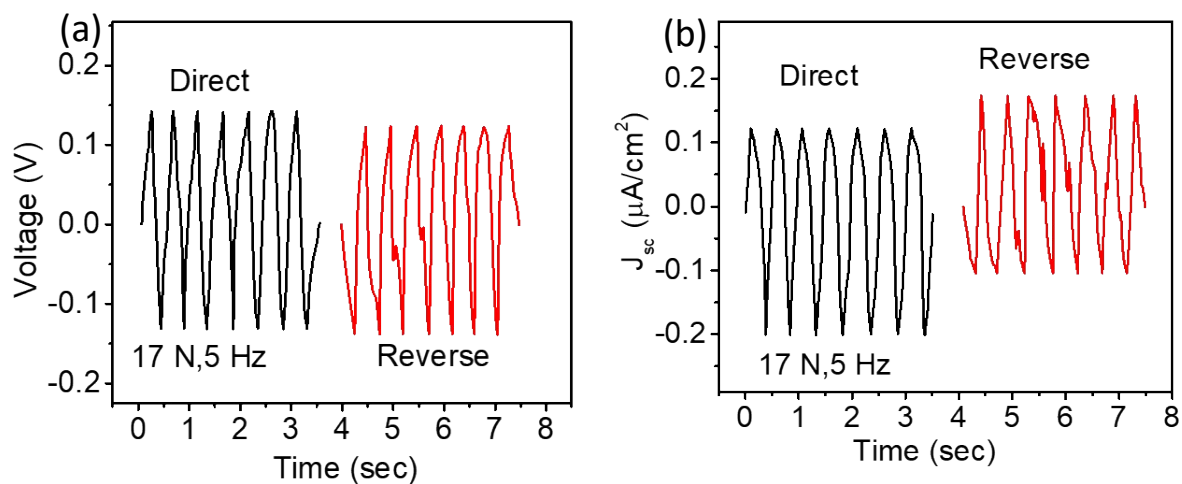
\*E-mail: [psuad4@iacs.res.in](mailto:psuad4@iacs.res.in); #Equally contributing



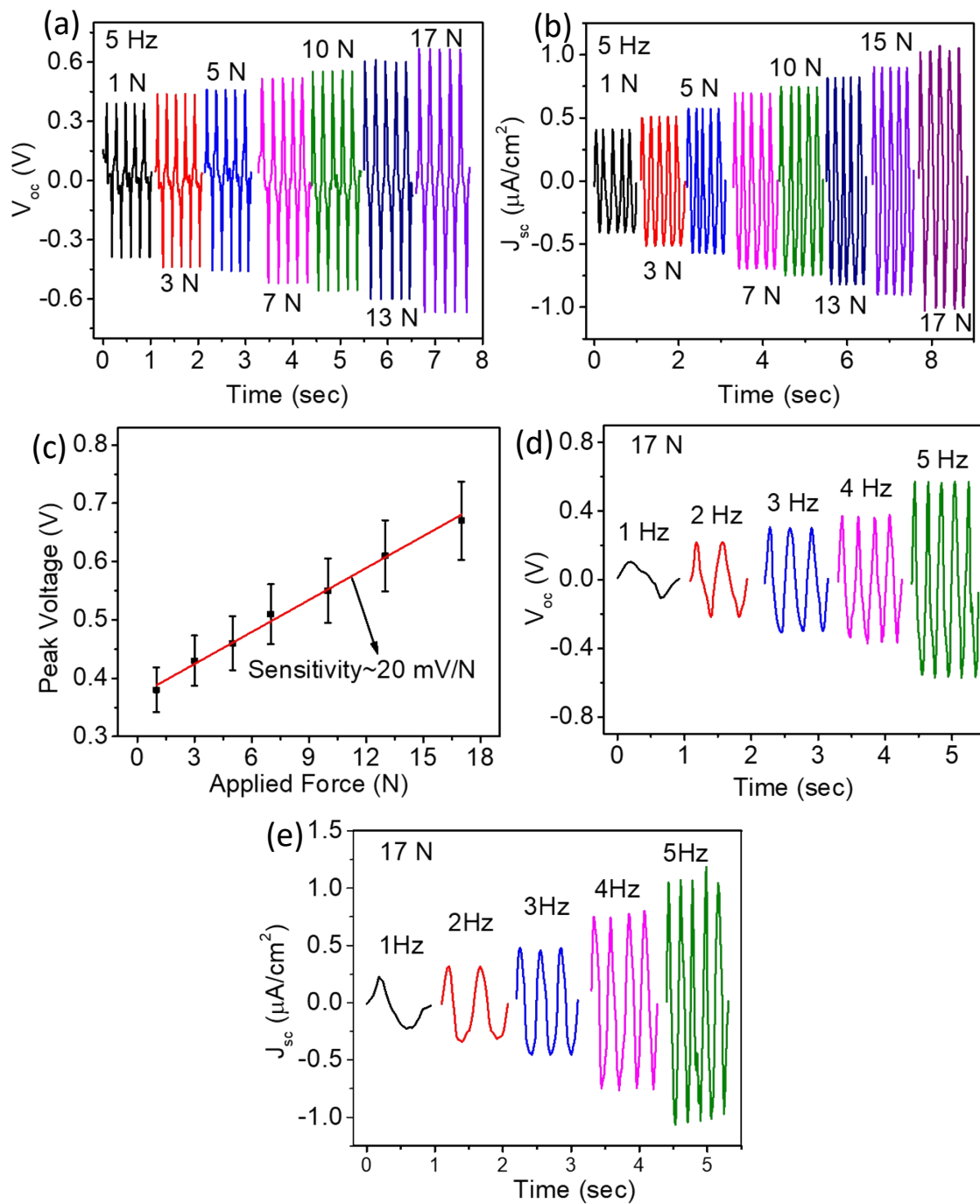
**Fig. S1** (a) Comparison of x-ray diffraction patterns of as-synthesized LN-ZTS NCs at different reaction time at 220° C. SEM and TEM images for (b) and (c) 12 h reaction, (d) and (e) for 6 h reaction for ZTS products.



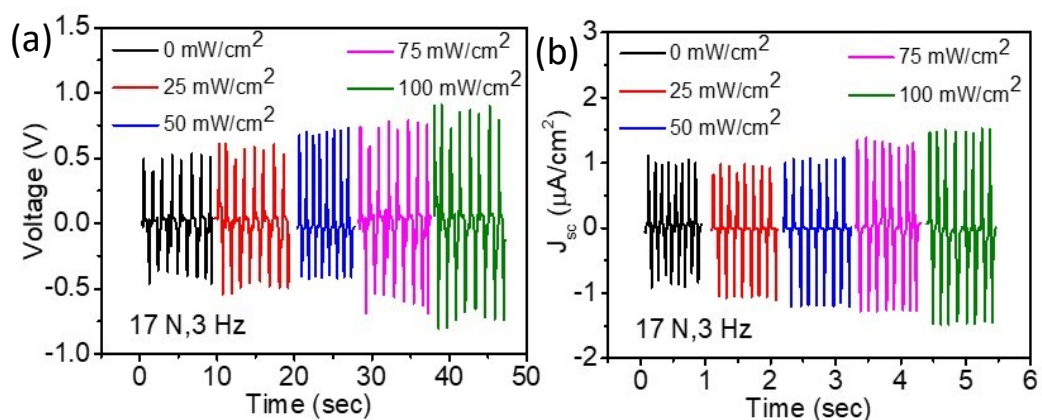
**Fig. S2:** (a) Topography image (b) Plot of the phase change of the LN-ZTS NCs film. (c) Butterfly loop and  $d_{33}$  plot. (d)-(e) amplitude images with the change of the bias voltage



**Fig. S3** Variation of (a)  $V_{oc}$  and (b)  $J_{sc}$  for direct and reverse connection from the LN-ZTS pellet at 17 N and 5 Hz.



**Fig. S4** (a and b) Variation of  $V_{oc}$  and  $J_{sc}$  with time under different applied forces at 5 Hz, (c) piezoelectric sensitivity showing the change in the peak voltage with applied force. (d and e) Variation of  $V_{oc}$  and  $J_{sc}$  with the time at different frequencies under 17 N applied force.



**Fig. S5:** (a) Changing of open circuit voltage and (b) short circuit current density with the changing of light intensity up to 100 mW/cm<sup>2</sup> at 17 N, 3Hz.

Materials	$V_{oc}$	$I_{sc}$	$P_{max}$	Applied force	$d_{33}$	Mechano sensitivity	Ref.
ZnS/PDMS/PANI	35 V	77.7 nA	2.43 $\mu$ W/cm <sup>3</sup>	13.6 Kpa	..... ...	.....	[1]
CdS nanowall arrays	1.2 V	6 nA	6.13 nW/cm <sup>2</sup>	..... (deformation)	.....	0.143 V/N	[2]
SnS <sub>2</sub> /PVDF	60 ± 4 V	8 ± 0.4 nA	87.11 $\mu$ W/cm <sup>2</sup>	100 N	..... .....	4.83 M/Pa	[3]
MoS <sub>2</sub> /TOCN	4.1 V	210 nA	.....	.....	31 PC/N	.....	[4]
WS <sub>2</sub> /PVDF	116 V	.....	48.5 $\mu$ W/cm <sup>2</sup>	.....		105 KPa	[5]
<b>LN-ZnSnS<sub>3</sub> nanoflakes</b>	<b>0.7 V</b>	<b>1 <math>\mu</math>A/cm<sup>2</sup></b>	<b>0.025 <math>\mu</math>W/cm<sup>2</sup></b>	<b>17 N</b>	<b>19 pm/V</b>	<b>20 mV/N</b>	<b>This work</b>

**Table S1.** Comparison of various parameters regarding piezoelectric energy harvesting of different sulphide-based nano/micro materials.

<b>Materials</b>	<b>Measurement parameter</b>	<b>Maxim-um Photov-oltage</b>	<b>Max. Photoc-urrent</b>	<b>Power output</b>	<b>d<sub>33</sub></b>	<b>Mechano-sensitivity</b>	<b>Ref.</b>
ZnO/ZnS Core/Shell Nanowires	365 nm UV radiation Power intensity 0.78 mW/cm <sup>2</sup> Compressive strain of -0.24%	.....	350 μA/cm <sup>2</sup>	.....	3.8 pm/V	.....	[6]
Carbon-Fiber/ZnO-CdS Double-Shell Microwire	UV-VIS light (372-548 nm) Compressive strain of -0.38%	.....	28 μA	.....	.....	.....	[7]
Cu <sub>2</sub> S/CdS Coaxial Nanowire	Compressive strain of -0.41%	0.29V	0.3 nA	.....	.....	.....	[8]
2D MoS <sub>2</sub>	Intensity of 4.297 mW/cm <sup>2</sup> by a 633 nm laser, Compressive strain of -0.38%	.....	220 nA	.....	.....	.....	[9]
<b>LN-type ZnSnS<sub>3</sub> nanoflakes</b>	<b>100 mW/cm<sup>2</sup> 17N, 3 Hz</b>	<b>0.8 V</b>	<b>1.3 μA/cm<sup>2</sup></b>	<b>0.13 μW/cm<sup>2</sup></b>	<b>19.3 pm/V</b>	<b>20 mV/N</b>	<b>This work</b>

**Table S2.** Comparison of various parameters of different piezophototronic sulphide-based nano/micro materials.

## References

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